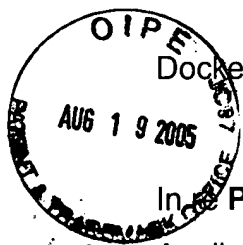


Docket No. 03-IMP-031

EATNP159US



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In ~~the~~ **PATENT** application of:

Applicants: Halling et al.

Application No.: 10/825,527

For: BEAM ANGLE CONTROL IN A BATCH ION IMPLANTATION  
SYSTEM

Filing Date: April 15, 2004

Examiner: Jack I. Berman

Art Unit: 2881

**REPLY TO OFFICE ACTION DATED JULY 26, 2005**

Mail Stop Amendment  
Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Favorable reconsideration of the above-identified application is respectfully  
requested in view of the following amendments and remarks.